Supplementary information

High photosensitivity and broad spectral response of multi-layered germanium sulfide transistors

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Materials	Spectral window	Channel thickness/ length	Measurement condition	Incident power	R _λ (A/W)	<i>τ</i> ι/ <i>τ</i> t	EQE (%)	D* (Jones)	Response time	Ref.
Multi-layered SnS2	Visible	~80 nm/ 2 μm	$V_{g} = 0 V$ $V_{ds} = 2 V$	0.24 μW	8.8×10 ⁻³ (457 nm)	~3.0×10 ⁻¹	NR	2×10 ⁹	~5 µs	S 1
Multi-layered SnS2	Visible	~108 nm/ 5 μm	$V_{ds} = 10 V$	1 mW/cm ²	2 (450 nm)	~5.1×10 ¹	NR	NR	~42 ms	S2
Multi-layered GeSe	IR	57 nm/ 10 μm	$V_{ds} = 4 V$	283 mW/cm ²	3.5 (808 nm)	~9.4×10 ²	530	NR	100 ms	S 3
GeS nanoribbon	Visible	41 nm/ 5 μm	$V_{ds} = 5 V$	$0.25 \ \mu W/cm^2$	139.9 (530 nm)	~8.0×10 ³	3.37×10 ⁴	NR	850 ms	S4
Multi-layered GeS	Visible	~28 nm/ 13 µm	$V_{g} = 0 V$ $V_{ds} = 10 V$ $V_{g} = -80 V$	1.5 μW/cm ² 10	206 (633 nm) 655	~1.4×10 ⁴	4×10 ⁴	2.35 ×10 ¹³	~7 ms	This work
			$V_{ds} = 10 V$	µW/cm ²	(633 nm)					

Table S1. Summary of performance metrics of the IV- VI group-based 2D photodetectors

 V_g : back gate voltage; V_{ds} : source-drain voltage; R_{λ} : photoresponsivity; τ_l/τ_l : ratio of carrier lifetime (τ_l) to transit time (τ_t); EQE: external quantum efficiency; D*: specific detectivity; NR: not reported.



Fig. S1 (a) Elemental mapping of the as-synthesized bulk GeS crystal. (b) EDS spectrum of the bulk GeS crystal. (c) Analysis of the weight and atomic percentages of the GeS crystal reveals the stoichiometric ratio of Ge:S of $\sim 1:1$.



Fig. S2 The measured I_{ds} -V_g curve of a multi-layered GeS-FET indicates the on/off current ratio of ~10⁵.



Fig. S3 An absorption spectrum of bulk GeS crystal was observed. In the inset, the band gap of the bulk GeS crystal is estimated to be ~ 1.63 eV by fitting the measured data to a Tauc's plot.



Fig. S4 D* of a multi-layered GeS photodetector as a function of V_g was measured at $V_{ds} = 10$ V and P = 10 μ W/cm² at 633 nm.



Fig. S5 Photoswitching stability of a GeS photodetector in response to a long train (~100 cycles) of pulsed illumination at P = 12.7 mW/cm² (λ = 633 nm), V_g = 0 V, and V_{ds} = 1 V.

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